

Docket Number: 081468-0308709
Client Reference: P-0224.011-US

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

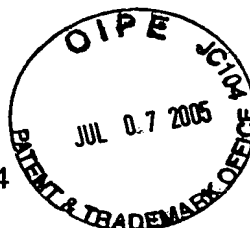
In Re the Application of

GUI et al.

Application No.: 10/803,104

Filed: March 18, 2004

For: LITHOGRAPHIC APPARATUS



Group Art Unit: 2851

Examiner: P. KIM

Confirmation No.: 5313

July 7, 2005

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. One copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the reference(s) has been considered, per MPEP § 609.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

I hereby certify that no item of information in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of this Information Disclosure Statement. 37 CFR 1.97(e)(2).

This application is one of a series of related applications, identified in the attached Appendix, which are directed to related technical subject matter. The identification of those U.S. Patent Applications is not to be construed as a waiver of secrecy as to those applications now or upon issuance of the present application as a patent. The Examiner is respectfully requested to consider the cited applications and the art cited therein during examination.

07/11/2005 HALI11 00000110 10803104

02 FC:1806 180.00 DA

GUI et al. - 10/803,104
Attorney Docket No. 081468-0308709

Please charge Deposit Account 033975 in the amount of \$180.00 in payment of the fee under 37 CFR 1.17(p). Please credit or debit Deposit Account 033975 as needed to ensure consideration of the disclosed information.

Respectfully submitted,

PILLSBURY WINTHROP SHAW PITTMAN LLP



Robert C. Perez
Reg. No. 39328

RCP/smm
P.O. Box 10500
McLean, VA 22102
Telephone: (703) 905-2000
Facsimile: (703) 905-2500
Customer No. 00909



APPENDIX

Examiner's Initials	First Inventor	Application No.	Filing Date	Enclosed
	GUI et al.	10/840,360	May 7, 2004	<input type="checkbox"/> Specification <input type="checkbox"/> Drawings <input type="checkbox"/> Other:
	GUI et al.	10/939,999	September 14, 2004	<input type="checkbox"/> Specification <input type="checkbox"/> Drawings <input type="checkbox"/> Other:

The Examiner's initials indicates he/she has considered the cited application relative to the subject application.

DO NOT PRINT the above information on the patent which results from the subject application.

FORM PTO-1449 (modified)
To: U.S. Department of Commerce
(PW FORM PAT-1449)
Patent and Trademark Office

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Client Ref.

308709

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**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**



Applicant: GUI et al.

Appln. No.: 10/803,104

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Group Art Unit: 2851

Date: July 7, 2005

Page

1

of

1

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR					
	BR					
	CR					
	DR					
	ER					
	FR					
	GR					
	HR					
	IR					
	JR					
	KR					
	LR					
	MR					

FOREIGN PATENT DOCUMENTS

ENGLISH PATENT DOCUMENTS							Abstract		Readily Available	
		Document Number	Date MM/YYYY	Country	Inventor Name		Enclosed	No	Enclose	No
	NR									
	OR									
	PR									
	QR									
	RR									
	SR									
	TR									
	UR									
	VR									

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

WR	Coulon, D., "Application Specific Lithography for MEMS," PowerPoint Presentation, Ultratech Stepper, January 31, 2003, 19 pages.			
XR	Ultratech Inc.: Key Developments, Fifty Collected Press Releases for Ultratech, Inc., dated from July 11, 2000 through June 13, 2005, located at http://news.moneycentral.msn.com/ticker/sigdey.asp?Symbol=US:UTEK , pages 1-8.			
YR				
ZR				
AAR				

Examiner

Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.